# FEATURE EXTRACTION METHODS FOR IC CHIP MARKING INSPECTION – A COMPARISON

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# **ABSTRACT**

In this paper, an Industrial machine vision system incorporating Optical Character Recognition (OCR) is employed to inspect the marking on the Integrated Circuit (IC) Chips. This inspection is carried out while the ICs are coming out from the manufacturing line. A TSSOP-DGG type of IC package from Texas Instrument is used in the investigation. The IC chips are laser printed. This inspection system ensures that the laser printed marking on IC chips is proper. The inspection has to identify the print errors such as illegible character, missing characters and up side down printing. The vision inspection of the printed markings on the IC chip is carried out in three phases namely image preprocessing, feature extraction and classification. MATLAB platform and its toolboxes are used for designing the inspection processing technique. Projection profile and Moments are employed for feature extraction. A neural network is used as a classifier to detect the defectively marked IC chips coming from the manufacturing line. Four different neural network input structures are considered for optimizing the training speed in projection profile extraction method and two different moments is used for moments feature extraction method. The performance of projection profile is compared with that of few feature extraction methodologies. In neural network, feature extracted from moments and projection profile are used for inspection. Both feature extraction methods are compared in terms of marking inspection time

طرق استخراج الميزات الخاصة بتأشير الدوائر المتكاملة — دراسة مقارنة

ار. نکاراجان و سازلی یعقوب و باولراج باندیان و کی کارنجیان و محمد رایزون

مدرسة الميكاترونك - كلية الهندسة - جامعة شمال ماليزيا

الحلاصة

يتناول البحث منظومة ضونية لتمييز الحروف لقحص عمليات التأثير على الدوائر التكاملة حيث تتم عملية المفحص عند خروج السدائرة المتكاملة من خط الإلتاج .

خلال هذه الدراسة استخدمت دواتر متكاملة مصنعة من قبل شوكة تكساس انسترومنت مطبوع عليها بواسطة الليزر . حيث بتم مسن خلال الكشف التأكد من جودة عملية الطبع . استخدم برنامج MATLAB لغرض عملية القحص .

# I.INTRODUCTION

Since 1950, Optical Character Recognition (OCR) has been very active in the application of automatic pattern recognition; now it is used to recognize the printed characters at high speed [1, 2]. At techniques are widely used in recognition of both hard written and printed character [1-4]. The OCR is applied for business card recognition [5] where the manual faput is optional; however, by scanning, the OCR is able to create an easier database. The document reading and analysis have reached an important place in certain markets. The application of OCR in the postal automation has followed into the banks and industrial inspection processes [6, 7].

IC chips play a vital role in electronic industries. Mass production of IC chips have brought down the price of the electronic products. Texas Instrument is one of the well-established IC chips manufacturing companies in the world market. In the Texas group, Texas Instrument, Malaysia, is one of the leading producers of IC chips in region of the world. The IC chips undergo many inspections and verifications to ensure a guaranteed quality. Quality control

of IC is performed by inspecting the placement of die, inspecting lead dimension, inspecting packaging and inspecting marking of symbols (IC number, year of manufacture and batch code etc). In this paper OCR is employed to check the markings of the IC chips especially, marking on the *Thin Shrink Small Outline Packages (TSSOP-DGG)* using neural network and fuzzy logic. Figure 1 illustrates various marking errors that can occur during production where as Figure 2 shows the error free marking.

# IL INDUSTRIAL SETUP

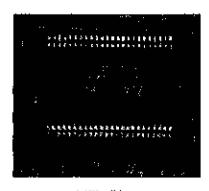
In Texas Instrument inspection set up, a digital video camera is used to capture the marking of IC chips coming out of manufacturing line one by one. These images are zoomed about 20 to 30 times in size. Figure 3 shows the dimensions of IC chip. The zooming index depends on the size of the IC chip. The earlier industrial version of inspection system checks about 7300 to 7500 IC chips per hour. IC chips undergo on fly inspection as shown in Figure 4 where OCR checks any defects in the markings on the ICs.

The software used in this inspection set up does not apply Al techniques. Instead, simple binary logic is employed in marking inspection. It has been found in Texas Instrument (M), the success rate of the inspection system is still to be improved. This paper investigates the application of Al techniques such as neural network in marking inspection of IC chips with an ultimate objective of modifying the existing software.

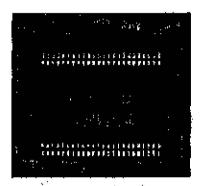
# III. MARKING INSPECTION PROCESS

In Texas Instrument (M), the IC chips are lined up in a running conveyor for marking inspection. The marking on the IC chips are captured as a movie clip by a Charged Couple Device (CCD) non-standard camera. Images of the IC chips are extracted from the Moving Picture Expert Group (MPEG) format. The software then identifies whether the IC marking is of good equality. IC with non acceptable quality of marking is rejected without identifying the type of errors in marking. In this paper more systematic procedure is proposed for inspecting and also for classifying IC chip marking.

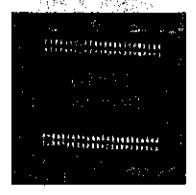
In this paper, the extracted images, thus captured, are made to undergo certain image processing techniques [6] namely preprocessing [1,7], feature extraction [8,9] and classification using AI techniques [10-13] These processing sequence are shown in Figure 5.



(a)Hlegible



(b) Upside Down Print



(c) Missing Character

Figure 1. IC Marking in Illegible Character Group

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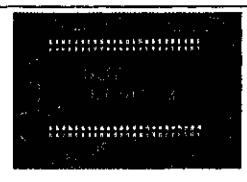


Figure 2. An Error Free Marking



Figuer 3. Dimension of IC chips



Figure 4, IC chips in the conveyor

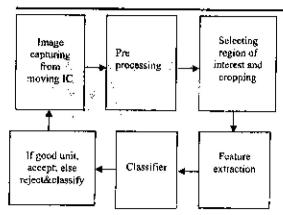


Figure 5. Image Processing Sequence

# Preprocessing

The inspection begins with the extraction of single image from the moving picture. The extracted color image is converted into a 256 gray scale image as shown in Figure 6. Then, the gray scale image is the binarized with a suitable threshold value as shown in Figure 7. The binarization converts the image pixels into '0' (black) and '1' (white). The threshold value differentiates the foreground and background of the given image. Threshold value is selected after performing a set of experiments using MATLAB. Region of Interest (ROI) specified by the production inspector is shown in Figure 8. If the ROI is not specified, a search forthe ROI from the extracted full image can be performed but it is time consuming. From the specified ROI area the sum of the white pixels of each row and those of each column are determined. Cropping marking from ROI is done by summing row and column of the ROI

The preprocessed image is cropped based on the presence of white pixel in the ROI area. The ROI white pixel is summed in row and column wise. The row sum is taken into consideration to split the two rows as shown in Figure 9 Then the column sum of each row creates the required ROI of each character

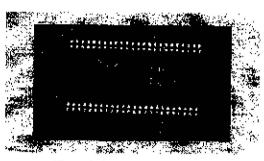


Figure 6. Grayscale Image



Figure 7. Binarized image



Figure 8. ROI Area of binarized image



Figure 9. Row sum for Separating Two Rows

#### Feature Extraction Methods

In this paper four different feature extraction methods are discussed for IC marking inspection and their performances are compared. The methods are Projection Profile, Moments, Zoning and contour profile Projection Profile:

The row-sum (P<sub>h</sub>) and column-sum (P<sub>v</sub>) features of each character are displayed as projection profiles. Horizontal projection (row sum) and vertical projection (column sum) as shown in Figure 10, are extracted for the each character image. Let S (n, m) be a binary image of n rows and m columns. Then,

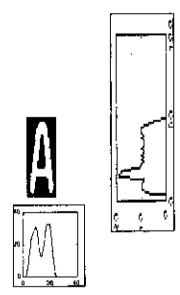


Figure 10. Projection Profile for Acceptable IC image "A"

Vertical Profile: Sum of white pixels of each column perpendicular to the x-axis; this is represented by the vector  $P_v$  of size n as defined by [8]:

$$\begin{array}{ll} P_{v}\left(i\right) = \sum\limits_{j=1}^{n} S\left[i,j\right], & i=1,2,3,...,m \end{array} \tag{1} \label{eq:pv}$$

Horizontal Profile: Sum of white pixels of each row perpendicular to the y-axis; this is represented by the vector  $P_E$  of size m

$$P_{i_1}[j] = \sum_{i=1}^{m} S[i_i, j], \quad j = 1,2,3,...,n$$
 (2)

Profile projection of an acceptable image character "A" and that of an illegible character "A" are shown in Figure 10 and Figure 11 respectively to differentiate the acceptable and illegible characters

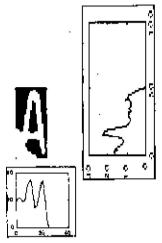


Figure 11. Projection Profile for Illegible Image "A"

#### **Moments**

Moments have been used in recognizing the printed and hand written characters and are also widely used in pattern recognition. There are different types of used for recognition moments characters; here Central moments of binary image for each column of the image orders are obtained. The image orders can be 2 or 3. In the order 1, moments values are zero. On the other hand, orders more than 3 produces smaller and smaller moments values that cannot be generally used for feature extraction.

Let f(x,y) be an image. Then, the 2D continuous function of the moment of order  $(p \nmid q)$ ,  $M_{pq}$ , is defined as [6].

$$M_{pq} = \int_{-\infty}^{\infty} \int_{-\infty}^{\infty} x^{p} y^{q} f(x, y) dx dy$$
 (3)

The central moment  $, \mu_{pq}, \text{ of } f(x,y)$  is defined as is [6].

$$\mu_{pq} = \int_{-\infty-\infty}^{\infty} \int_{-\infty}^{\infty} (x - \overline{x})^p (y - \overline{y})^q f(x, y) dx dy$$
(4)

where 
$$\overline{x} = \frac{M_{10}}{M_{00}}$$
 and  $\overline{y} = \frac{M_{01}}{M_{66}}$ .

If f(x,y) is a digital image then equation (2) becomes

$$\mu_{pq} = \sum_{x} \sum_{y} (x - \overline{x})^{p} (y - \overline{y})^{q} f(x, y)$$

where p and q are nonnegative integer values.

The moment values are considered for extracting the feature. This method takes the central moments value of each column of the binary image.  $D_i$ , i = 1,...,k is the central moment value of each column from 0 to k of the marking.  $D_i$  can be computed using Equation (5). In this work k is taken as 25.

### Zoning

Zoning feature extraction method has been performed. The term "zone" implies a segmentation of more complex spatial realities. It has a high degree of similarity with the term "region". Zoned region of the image will be same through out image processing. Zoning is widely used in commercial OCR system. The recognizer uses information about the word shape. As this information is strongly related to word zoning [14]. It was designed to recognize the machine printed characters. A two level zoning is shown in Figure, 12. Here, the image is separated into two portions as top and bottom zones. The presence of white pixels in each zone is summed up,

Zoning is applied to marking but this has a limitation. The sum of each zone, some

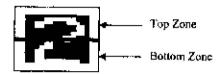
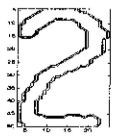


Figure 12. Two Level Zoning for Character "2"

times, will be the same value even though it is illegible. But by taking both zone sum values, the marking can be classified. These sums of each zone can be taken as features of top and bottom zones.

#### Contour Profile

A point operation can add lines to an image. One can also accomplish thresholding with a point operation that divides an image into disjoint regions on the basis of gray level. This is useful for defining boundaries. This is called contour profile. Contour profile is one of the fundamental techniques used for object identification in the field of pattern recognition [15]. The contour projection for character '2' is presented in Figure 13. The outer vertical and horizontal profiles of black pixels in white background are computed. These profiles are unique for any alphanumeric characters and have been used as features [9].



Pigure 13, Contour Image for "2"

# JV. FEATURE EXTRACTION PROCESSING TIME

in addition to projection profile, other feature extraction methods such as moments, contour profile and zoning [9] are considered for determining the processing time. Processing time is important in real-time industrial inspection Among these four of marking of IC. extraction features methods. processing by projection profile requires less time compared to other three methods. The moments processing is higher but nearer to profile projection processing time, so we have considered moments also Table 1 illustrates the feature. effectiveness of projection profile and moments as the methodology feature extraction.

#### V. MARKING INSPECTION USING NEURAL

#### NETWORK

Recently, there has been a high level of interest in applying artificial neural network for solving many problems [10-13]. The application of neural network gives easier solution to complex problems such as character recognition. Here, neural network is employed to classify the character by the extracted features (row and column profiles and moments of different order). A feed forward neural network is proposed to identify acceptable or to classify the various types of errors in marking as shown in Figure 14 and Figure 15 respectively. The moments value for two different orders such order 2 and order 3 and projection profile data (extracted features) are considered for training. The extracted features are taken as input to the network model.

The network consists of 4-output neurons and 1- hidden layer of 20 neurons. The output of the neural network cannot be

binary since the weight updating algorithm and activations are analog. However, each output can be made to converge either towards zero or towards one. additional analog-digital 'modifier' included at the output in orders to get binary output data. The binary output neuron gives the classification as shown in Figure 14 and Figure 15, In order to determine the output input size of the neural network in term of minimizing the time; the network is trained with different input sizes such as 28 neurons (14 rows + 14 columns), 38 neurons (25 rows + 13 columns), 75 neurons (50 rows + 25 columns) and 94 neurons (63 rows + 31 columns) and It has been trained for moments order 2 and 3. Zooming control of camera can offer these character size in terms of pixels

The networks with each of the above mentioned data are trained using a backpropagation training algorithm. The learning parameters for projection profile

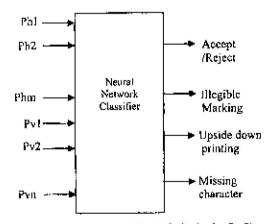
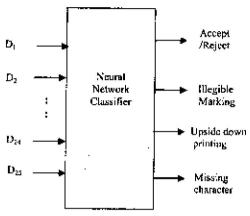


Figure 14. Neural Network Model for Projection Profile

Table 1 Processing Time for Each Methodology

and moments are chosen as given in Table and Table 3 respectively: cumulative errors versus epoch. characteristics. offor the training projection profile are shown in Figure 16 -Figure 19 and for moments (order2 and order 3) are shown in Figure 20 and, Figure 21.



Figure, 15 Neural network model for mannents

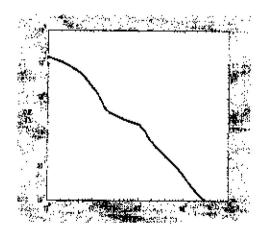


Figure 16 Cumulative Error (C.E) versus Epoch Plot for 28 input for Neural Network Classifier

Methodology Feature Extraction	Processing Activities	Process- lng Time
Extraction	Banding in the	
Projection	Reading image, gray scale, binary image,	0.1900 -
profile	cropping the image,	0.2100
!	taking projection	sec
1	profile to the	
	cropped, Taking row	
	sum and column sum	
1	and writing it to a	
L	file.	i
	Reading image, gray	
Moments	scale, bicary image,	0.2610 -
ı	cropping the image.	0.2710
	taking moments to	sec
ļ	the cropped and	
	writing it to a file.	<u> </u>
	Readittg image, gray	
<sup>1</sup> Zoning	scale, binary image,	0.3310
ľ	cropping the image,	0.3600
	separating the	šec
	cropped marking into	
	2 zones, Taking sum	[ ]
	of two zones	i l
1	separately and	
	writing it to a file,	
	Reading image, gray	
Contour Profile	scale, binary image,	1.0620 -
I I	cropping the image,	1.2020
	taking contour to the	sec
	cropped, take row	
	sum and column sum	ĺ
	and writing it to a	
	file.	i

The networks with each of the above listed input sizes are trained using a backpropagation training algorithm. The learning parameters are chosen as in Table 1 and Table 2: These figures indicate a reasonable convergence characteristic. The time and epoch details are given in Table 1 and Table 2.

The Training is carried out for 12 times in each case by reshuffling input data with the same network model. Table 2 and table



Figure 17 Cumulative Error (C.E) versus Epoch Plot for 38 input for Neural Nerwork Classifier

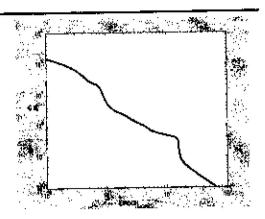


Figure 19, Cumulative Error (C.E) versus Epoch Plot for 94 input for Neural Network Classifier

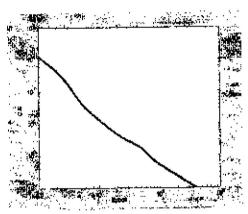


Figure 18. Cumulative Error (C.E) versus Epoch Plot for 75 input for Neural Network Classifier

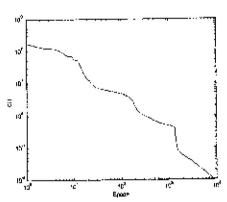


Fig. 20 Cumulative error versus epoch plot for moments second order

3 indicate the maximum and minimum epoch and duration of convergence in seconds within 12 trials. 'Ave' is the mean value among all 12 trials.

The cumulative errors are made to converge to the training and testing tolerance levels. Among the four different input training, the optimum input size for a fast processing is determined as (50+25) as shown in Figure 22.

#### VI. CONCLUSION

Al techniques such as neural network are applied to marking inspection of IC chips. The preprocessing and two feature extraction methods have been suggested for this inspection. A feed forward neural network has been developed for training and testing the samples of marking, have been involved in this training. Trainings are carried out for moments order 2, moments order 3 and projection profile

using backpropagation algorithm. Comparing moments order 2 and order 3, order 3 is faster for training. Among these training, projection profile is found to be faster in training. The projection profile method of marking classification can be used for real time application such as marking inspection whe

n the IC chips are coming out of manufacturing line in semiconductor industries. Processing time for different feature extraction has been carried out. Among feature extraction projection profile and moments are found to be faster than other two. Two different feature extraction (moments and projection profile) method

Table 2 Data Trained for Different Input Sizes of Neural Network

BackI	Propaga	tion Algori	lth m	No	of trains	ng of e	ach inp	ut size:	12 cimes	
Output neurons: 4			His	Hidden neurons: 20 1				Learning rate: 0.25		
Activation function: (1/(1+e <sup>-5</sup> ))			Mo	Momentum factor: 0.87				No. of samples tested :		
664		Tr	aining t	olerance	∌: 0.01		No	of train	ed samples: 400	
Testin	g tolerm	nce: 0. t							-	
S.No	Input	Training	No. of Epoch			Time(Sec)			Mesclassification	
	Size	Epoch	Min	Max	Ave	Min	Max	Ave	rusciassification	
ı	28	4500	4400	3165	3860.5	186	132	162.2	0	
2	38	2200	2201	1633	1961	116	87	103.6	0	
	75	2000	1012	724	896.6	86	62	73.8	D.	
3	1									

Table 3. Data Trained for Two Different Moments order for Neural Network

BackPropagation Algorithm			Trair	Training done: 12 times				Testing tolerance: 0.05		
Outpu	t neuron	neurons: 4 Hidden neurons: 20 Learning rate			ming rate: 0.2					
Activa	Activation function: $(1/(1+e^{-x}))$				Momentum factor: 0.87				of samples: 664	
Тгаілі	ng tolera	лсе: 0.01		No.	of train	ed sam:	ples: 40	0		
<b></b>	25.1	Training	No. of Epoch			Time(Scc)				
S.No G	Order	Epoch	Min	Max	Αve	Min	Max	Ave	Misclassification	
1	2	16000	8414	16567	9254	316	624	401	O	

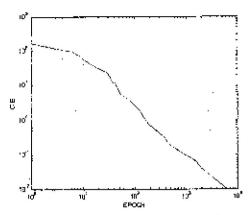


Fig. 21: Cumulative error versus epoch plot for moments third order

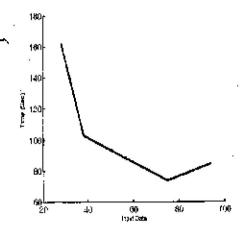


Figure 22. Input Data and Time for Convergence

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